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INFORMATION DISCLOSURE STATEMENT

Attorney Docket No.	Serial No.
2846/2112	10/660,348
Applicant(s): Ren et al.	
Filing Date: Setpember 11, 2003	Group: 1775

U.S. PATENT DOCUMENTS

Examiner Initial		Patent No.	Date	Name	Class	Subclass	Filing Date (if appropriate)
		6,855,202	February 15, 2005	Alivisatos et al.	117	68	November 20, 2002
		6,863,943	March 8, 2005	Wang et al.	428	37	January 13, 2004

FOREIGN PATENT DOCUMENTS

Examiner Initial		Document No.	Publication Date	Country	Class	Subclass	Translation	
							YES	NO

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)

	A	International Search Report based on PCT/US03/28530 dated April 7, 2005.

EXAMINER

DATE CONSIDERED 10/13/05

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

**Copies of references not provided at the time of this submission.

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	A	Park, W.I. et al., Metalorganic Vapor-Phase Epitaxial Growth of Vertically Well-Aligned ZnO Nanorods, Applied Physics Letters, 2002, Vol. 80, No. 22, pp. 4232-4234.
	B	Park, W.I. et al., ZnO Nanoneedles Grown Vertically on Si Substrates by Non-Catalytic Vapor-Phase Epitaxy, Advanced Materials, 2002, Vol. 14, No. 24, pp. 1841-1843.
	C	Suscavage, M. et al., High Quality Hydrothermal ZnO Crystals, MRS Internet J. Nitride Semicond. Res. 4S1, G3.40 (1999), 6 pgs.

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